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INFORMATION DISCLOSURE STATEMENT BY APPLICANT Date Submitted: October 18, 2007 <i>(use as many sheets as necessary)</i>				Application Number	10/526,745
				Filing Date	10/29/2003
				First Named Inventor	Katsuya HASEGAWA
				Art Unit	1793
				Examiner Name	Wartalowicz, Paul A
Sheet	1	of	1	Attorney Docket Number	017700-0174

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

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/K.M.V./	A1	Aaron, Austin (Examiner), Office Action for U.S. Application No. 10/526,896, mailing date September 20, 2007	
/K.M.V./	A2	English Translation of Preparation of SmBA ₂ Cu ₃ O _y Films with Improved In-Plane Alignment by Pulsed Laser Deposition; J. Japan Inst. Metals, Vol. 66, No. 4 (2002) pp 320-328.	

Examiner Signature	/Kallambella Vijayakumar/	Date Considered	03/25/2008
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